

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ohtomo et al.

Application No.: Con. Appln. of Art Unit: 2852
08/935,445

Filed: August 25, 1998 Examiner: S. Virmani

For: STAGE UNIT, DRIVE TABLE, AND Attorney Docket No.:
SCANNING EXPOSURE APPARATUS 7954-151
USING SAME

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants respectfully submit the following
amendments together with the request for filing a continuation
application.

IN THE CLAIMS:

Kindly add new claims as follows.

24. (New) A stage apparatus for scanning an object
of scanning which includes at least one of a mask and a
photosensitive substrate, said stage apparatus being provided
to a scanning exposure apparatus which illuminates said mask
on which a transfer pattern is formed and scans said mask in a
predetermined scanning direction and synchronously scans said
substrate in a direction corresponding to said scanning
direction, thereby exposing said pattern on said mask onto
said substrate, comprising:

a base;

a scanning stage arranged to be freely moved in said
scanning direction on said base;